



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Nathan R. Brown

Serial No.: 10/715,264

Filed: November 17, 2003

For: METHODS FOR DETERMINING
AMOUNTS AND LOCATIONS OF
DIFFERENTIAL PRESSURE TO BE
APPLIED TO SEMICONDUCTOR
SUBSTRATES DURING POLISHING OF
SEMICONDUCTOR DEVICE
STRUCTURES CARRIED THEREBY AND
FOR SUBSEQUENTL

Confirmation No.: 5086

Examiner: S. Macarthur

Group Art Unit: 1763

Attorney Docket No.: 2269-4375.3US

(99-1029.03/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

July 22, 2005

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Signature

Erika Gandre
Name (Type/Print)

AMENDMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This communication is being filed in response to the rejections presented in the Office Action mailed on April 22, 2005, the three-month shortened statutory period for response to which expires on July 22, 2005.

Amendments to the claims are set forth in the listing of the claims that begins on page 2 of this paper; and

Remarks start at page 5 of this paper.